1. **山口 裕之, 石田 三千雄, 村上 理一, 宮田 憲治, 山口 修二, 村田 貴信 :** 科学技術と倫理, 株式会社 ナカニシヤ出版, 京都, 2007年2月.
2. **YOON HAN-KI, KIM HYOUNG O, Dohoon Shin *and* Ri-ichi Murakami :** Nano-Indenter Mechanical Properties of ITO/Glass Thin Film Deposited By DC Magnetron Sputtering Method at Low Temperature, *International Journal of Modern Physics B,* **Vol.20,** *No.25-27,* 4322-4327, 2006.
3. **Z.Y Qiu, Dohoon Shin, K Nakada, Ri-ichi Murakami *and* H.Y Yoon :** Influence of the SiO and SiON Buffer Layer on IZO Thin Films Deposited on PET by Inclination Opposite Target Type DC Magnetron Sputtering Method, *International Journal of Modern Physics B,* **Vol.20,** *No.25-27,* 3640-3645, 2006.
4. **Hiroshi Yamakawa, Ri-ichi Murakami, Daisuke Yonekura, H. S. Lee *and* Nu Yan :** Fatigue Properties of a T Type Welded Joint in a Small Sized Single Pass Boiler Header, *International Journal of Modern Physics B,* **Vol.20,** *No.25n27,* 3836-3841, 2006.
5. **Daisuke Yonekura *and* Ri-ichi Murakami :** Influence of Ion Bombardment on Critical Load of CrN Film Deposited onto Aluminum Alloy by Arc Ion Plating Method, *International Journal of Modern Physics B,* **Vol.20,** *No.25n27,* 3842-3847, 2006.
6. **Ri-ichi Murakami, Katsuhiro Fujikawa *and* Daisuke Yonekura :** Improvment of Oxidation Property of SUS304 by Gas barrier Coating, *Key Engineering Materials,* **Vol.353-358,** 1879-1882, 2007.
7. **Satoshi Fukui, Ri-ichi Murakami *and* Daisuke Yonekura :** Effects of Dynamic lon Mixing Coating Condition for Fatigue Properties of Stainless Steel with TiN Film, *Key Engineering Materials,* **Vol.353-358,** 1875-1878, 2007.
8. **Nu Yan, Lee I., Daisuke Yonekura *and* Ri-ichi Murakami :** Influence of plasma ion nitriding on the fatigue properties of SCM435 steel, *Asian Pacific Conference for Fracture and Strength 2006,* Sanya, Nov. 2006.
9. **Daisuke Yonekura, H. Fukuda *and* Ri-ichi Murakami :** Influence of bias voltage on fatigue cracking behavior of chromium nitride film deposited on steel, *Asian Pacific Conference for Fracture and Strength 2006,* Sanya, Nov. 2006.
10. **Ri-ichi Murakami, K Fujikawa *and* Daisuke Yonekura :** Improvement of Oxidation Property of SUS304 by Gas barrier Coating, *Asian Pacific Conference for Fracture and Strength 2006,* Sanya, Nov. 2006.
11. **Ri-ichi Murakami, S Fukui, Daisuke Yonekura *and* Cheol-Mun Yim :** Study of boron-doped diamond films by microwave plasma CVD method, *Asian Pacific Conference for Fracture and Strength 2006,* Sanya, Nov. 2006.
12. **Daisuke Yonekura, T Ishikawa *and* Ri-ichi Murakami :** Influence of ion bombardment process on adhesion between CrN coatings and aluminum alloy, *Asian Pacific Conference for Fracture and Strength 2006,* Sanya, Nov. 2006.
13. **Yukihiro Tokunaga, Nu Yan, Daisuke Yonekura *and* Ri-ichi Murakami :** Thermal fatigue properties of the fin in the boilers, *Asian Pacific Conference for Fracture and Strength 2006,* Sanya, Nov. 2006.
14. **Satoshi Fukui, Ri-ichi Murakami *and* Daisuke Yonekura :** Effects of Dynamic Ion Mixing Coating Condition for Fatigue Properties of Stainless Steel with TiN Film, *Asian Pacific Conference for Fracture and Strength 2006,* Sanya, Nov. 2006.
15. **Hiroshi Yamakawa, Nu Yan, Daisuke Yonekura *and* Ri-ichi Murakami :** Fatigue properties of a T type welded joint in a small-sized single pass boiler header, *Asian Pacific Conference for Fracture and Strength 2006,* Sanya, Nov. 2006.
16. **孫 建軍, 村上 理一, 燕 怒, Insup Lee :** SCM435 鋼の超長寿命疲労強度に及ぼすラジカル窒化条件の影響, *日本機械学会講演論文集, No.075-1,* 2007年3月.
17. **村上 理一, 他35名 :** 電波吸収体の技術と応用Ⅱ, 株式会社 シーエムシー出版, 東京, 2008年1月.
18. **Kim Seong-Hoon, Yoon Han-Ki *and* Ri-ichi Murakami :** The effects of SiO, SiON on IZO thin Film Deposited by DCMG Method, *Diffusion and Defect Data Pt.B: Solid State Phenomena,* **Vol.124-126,** 455-458, 2007.
19. **Z.Y. Qiu, Ri-ichi Murakami, Daisuke Yonekura *and* J. Ueno :** Effect of the interface on the electrical properties of an Indium zinc oxide /SiOx multilayer, *Thin Solid Films,* **Vol.515,** *No.18,* 7259-7263, 2007.
20. **Kim Do-Hyoung, Yoon Han-Ki, Dohoon Shin *and* Ri-ichi Murakami :** Electromagnetic Wave Shielding Properties of ITO/PET Thin Film by Film Thickness, *Key Engineering Materials,* **Vol.345-346,** 1585-1588, 2007.
21. **H Yamakawa, Nu Yan, Daisuke Yonekura *and* Ri-ichi Murakami :** Fatigue Properties of a T Type Welded Joint in a Small-sized Single Pass Boiler Header, *Key Engineering Materials,* **Vol.353-358,** 2057-2060, 2007.
22. **Y. Tokunaga, Nu Yan, Daisuke Yonekura *and* Ri-ichi Murakami :** Thermal Fatigue Properties of the Fin in the Boilers, *Key Engineering Materials,* **Vol.353-358,** 315-318, 2007.
23. **Nu Yan, I. Lee, Ri-ichi Murakami, Daisuke Yonekura, J. Sun *and* S Fukui :** Influence of Plasma Radical Nitriding on Fatigue Properties of SCM435 Steel, *Key Engineering Materials,* **Vol.353-358,** 266-269, 2007.
24. **Nu Yan, H Yamakawa., Ri-ichi Murakami *and* Daisuke Yonekura :** Elevation of fatigue behavior of T-type welded joint in the small-sized single pass boiler, *journal of Pressure Equipment and Systems,* **Vol.5,** 80-83, 2007.
25. **Daisuke Yonekura, Hiroyuki Fukuda *and* Ri-ichi Murakami :** Influence of Deposition Bias Voltage on Fatigue Cracking Behavior of Chromium Nitride Film Deposited on Steel, *Key Engineering Materials,* **Vol.353-358,** 275-278, 2007.
26. **Ri-ichi Murakami, Shinichiro Fukui, Daisuke Yonekura *and* Cheol-Mun Yim :** Study of Boron-doped Diamond Films by Microwave Plasma CVD Method, *Key Engineering Materials,* **Vol.353-358,** 1883-1886, 2007.
27. **Daisuke Yonekura, Tomoyuki Ishikawa *and* Ri-ichi Murakami :** Influence of lon Bombardment Process on Adhesion between CrN Coatings and Aluminum Alloy, *Key Engineering Materials,* **Vol.353 358,** 1887-1890, 2007.
28. **Nu Yan, H Yamakawa, Ri-ichi Murakami *and* Daisuke Yonekura :** Elevation of fatigue behavior of T-type welded joint in the small-sized single pass boiler, Changsha,Hunan,China, Oct. 2007.
29. **原内 裕司, 村上 理一, 米倉 大介 :** 熱処理によるTiN薄膜からのTiOxNy薄膜の作製と光分解特性, 2007年5月.
30. **石川 智之, 米倉 大介, 村上 理一 :** CrN薄膜/アルミニウム基板界面の性状に及ぼすイオンボンバード処理の影響, 2007年9月.
31. **長岡 宏樹, 米倉 大介, 村上 理一 :** CrN薄膜被覆鋼の疲労強度に及ぼす膜性状の影響, 2007年9月.
32. **藤川 甲宇, 米倉 大介, 村上 理一 :** ガスバリア膜の被覆によるステンレス鋼の高温酸化特性の改善, 2007年9月.
33. **Nu Yan, Sun Jianjun, Lee Insup *and* Ri-ichi Murakami :** Effect of plasma nitrocarburizing on fatigue strength of SCM435 steel, *Journal of Pressure Equipment and Systems,* **Vol.6,** 25-28, 2008.
34. **Pangpang Wang, Lumei Gao, Zhiyong Qiu, Xiaoping Song, Liqun Wang, Sen Yang *and* Ri-ichi Murakami :** A multistep ac electrodeposition method to prepare Co nanowires with high coercivity, *Journal of Applied Physics,* **Vol.104,** *No.6,* 064304-064308, 2008.
35. **Shamimur Md. Rahman, T. Md. ShamimurKatsuma Rahman, Daisuke Yonekura *and* Ri-ichi Murakami :** Effect of Bias Voltage on Fatigue Behavior of CrN Film Deposited on Ti-Al-4V Alloy, *Proceedings of the 3rd International Conference on Material and Processing 2008,* Chicago, Oct. 2008.
36. **Qiu Zhiyong, Wang Pangpang *and* Ri-ichi Murakami :** THE PREPARATION AND PROPERTIES OF ZINC OXIDE/SILVER/ZINE OXIDE MULTILAYER TRANSPARENT CONDUCTIVE OXIDE THIN FILMS DEPOSITED BY A D.C. MAGNETRON SPUTTERING SYSTEM, *Proceedings of the 3rd International Conference on Material and Processing 2008,* Chicago, Oct. 2008.
37. **Daisuke Yonekura, T. Ishikawa *and* Ri-ichi Murakami :** Effect of Ion Bombardment on Adhesive Strength of Hard Thin Film Deposited on Aluminum Alloy, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
38. **Masaya Takahashi, Daisuke Yonekura, Ri-ichi Murakami *and* Masahiro Katoh :** The influence of surface roughness of substrate on SiO2 powders-steel adhesion, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
39. **Y. Nishioka, Daisuke Yonekura *and* Ri-ichi Murakami :** Influence of interlayers on tribological properties of CrN deposited on aluminum alloy, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
40. **Y. Harauchi, Daisuke Yonekura *and* Ri-ichi Murakami :** Photocatalytic Properties of a TiOxNy Film Obtained by Oxidation of TiN Film, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
41. **K. Oka, Daisuke Yonekura *and* Ri-ichi Murakami :** Electrochemical Properties of Boron-doped Diamond Deposited by Microwave Plasma CVD Method, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
42. **K. Kario, Daisuke Yonekura *and* Ri-ichi Murakami :** Oxygen Solubility and Diffusibility of SiOxNy Films Deposited by DC Magnetron Sputtering, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
43. **H. Nagaoka, Daisuke Yonekura *and* Ri-ichi Murakami :** Fatigue Properties of Medium Carbon Steel Deposited with CrN and TiAlN Film, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
44. **T. Katsuma, Shamimur Md. Rahman, Daisuke Yonekura *and* Ri-ichi Murakami :** Evaluation of Crack Initiation and Fatigue Behavior of CrN Film Deposited on Ti-6Al-4V Alloy, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
45. **Wang PangPang, Qiu Zhiyong, Gao Lumei, Wang Liqun, Ri-ichi Murakami *and* Song Xiaoping :** Preparation and field emission properties of Ag nanorod arrays by AAO template synthesis method, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
46. **Wang PangPang, Gao Lumei, Wang Liqun, Yang Sen, Song Xiaoping *and* Ri-ichi Murakami :** Magnetic properties of FeNi nanowires array assembled by AC electrodeposition on porous AAO template, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
47. **Lee Chan-joo, Ri-ichi Murakami *and* Suh Chang-min :** Fatigue properties of aluminum alloy(A6061-T6) with ultrasonic nanocrystal surface modification, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
48. **Cao Xiaojian, Ri-ichi Murakami *and* Wang Qingyuan :** Fatigue properties of Ti-6AI-4V subjected to 0.9% physiogical saline solution, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
49. **Cao Xiaojian, Ri-ichi Murakami *and* Wang Qingyuan :** Fatigue properties of Ti-6AI-4V sterilized by 75% medical alcohol, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
50. **Ri-ichi Murakami *and* Shin Do-Hoon :** Effect of process parameters on electrical, optical and electromagnetic shielding properties on IZO films produced by Inclination Opposite Target Type DC Magnetron Sputtering at room temperature, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
51. **Fukui Satoshi, Daisuke Yonekura *and* Ri-ichi Murakami :** Influence of deposition conditios on ftigue properties of martensitic steel with TiN film coated by Arc Ion plating method, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
52. **Yim Cheolmun *and* Ri-ichi Murakami :** Chemical Modification of Diamond Films on Pure Titanium Deposited By MPCVD Method, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
53. **Yoon H.K., Ri-ichi Murakami *and* Oiu Z. :** Patterning of indium Zn oxide by photolithography for fabrication of flat-pannel displays, *International Conference on Advanced Materials Development & Performance 2008,* Beijing, Oct. 2008.
54. **Nu Yan, Sun Jianjun, Insup Lee *and* Ri-ichi Murakami :** Effect of plasma nitrocarburizing on fatigue strength of SCM435 steel, *Journal of Pressure Equipment and Systems,* **Vol.6,** 25-28, Oct. 2008.
55. **日下 一也, 高木 均, 米倉 大介, 長町 拓夫, 英 崇夫 :** 設計-製作分離型ものづくり実習の試み, *平成20年度工学・工業教育研究講演会 講演論文集,* 66-67, 2008年8月.
56. **米倉 大介 :** コーティング材の転がり摩耗損傷および薄膜の密着強度, *第128回破壊力学部門委員会講演会資料,* **Vol.57,** *No.2,* 49-58, 2008年11月.
57. **Satoshi Fukui, Daisuke Yonekura *and* Ri-ichi Murakami :** EFFECT OF BIAS VOLTAGE ON THE FATIGUE LIFE OF MARTENSITIC STAINLESS STEEL WITH TiN FILM COATED USING ARC ION PLATING METHOD, *International Journal of Modern Physics B,* **Vol.23,** *No.15,* 3213-3220, 2009.
58. **Pangpang Wang, Dongyan Zhang, Kim Hun Dong, Qiu Zhiyong, Gao Lumei, Ri-ichi Murakami *and* Xiaoping Song :** Enhancement of light transmission by coupling to surface plasmon polaritons of a layer-plus-islands silver layer, *Journal of Applied Physics,* **Vol.106,** *No.10,* 103103-103104, 2009.
59. **Daisuke Yonekura, Yuji Harauchi, Syuhei Katsura *and* Ri-ichi Murakami :** Influence of Heat Treatment Conditions on Photocatalytic Properties of Oxidized TiN Film, *Journal of Solid Mechanics and Materials Engineering,* **Vol.3,** *No.12,* 1238-1248, 2009.
60. **Kim Dong-Hun, Ri-ichi Murakami, Kim Yun-Hae, Moon Kyung-Man, An Seung-Jun, Kim Tae-Hyun *and* Pangpang Wang :** The Characteristics of Multilayer Thin Films Deposited with Metal Thin Film(Ag, Al, Cu), *Advanced Materials Research,* **Vol.97-101,** 1768-1771, 2010.
61. **Pankaj Koinkar *and* Ri-ichi Murakami :** A New Approach on Engineering Education in Global Graduate School Program, *Journal of University Education and Research,* **Vol.7,** 85-93, 2010.
62. **Daisuke Yonekura, Yuji Harauchi, Syuhei Katsura *and* Ri-ichi Murakami :** Influence Of Heat Treatment Conditions on Photocatalytic Properties of Oxidized TiN film, *Proceedings of 4th RAMM and 2nd ASMP 2009,* Penang, Jun. 2009.
63. **Pankaj Koinkar, Daisuke Yonekura, T. G. Kim, M. A. More *and* Ri-ichi Murakami :** Field emission investigation of boron doped diamond thin films synthesized by microwave plasma chemical vapor deposition : Effect of vacuum annealing, *Technical Digest of 2009 22nd International Vacuum Nanoelectronics Conference,* 247-248, Hamamatsu, Jul. 2009.
64. **Pangpang Wang, Lumei Gao, Xiaoping Song, Sen Yang, Wang Liqun *and* Ri-ichi Murakami :** Crystal Growth and Magnetic Reversal Mechanism in FerromagneticNanowire by Chain of Prolate Spheroids Model, *General Poster Session,* 153-158, Oct. 2009.
65. **Dong-Hun Kim, Ri-ichi Murakami, Yun-Hae Kim, Kyung-Man Moon, Seung-Jun An *and* Pangpang Wang :** The Characteristics of Multilayer Thin Films Deposited with Metal Thin Films (Ag, Al, Cu), *Advanced Materials Research,* **Vol.97-101,** 1768-1771, Mar. 2010.
66. **桂 修平, 原内 裕司, 米倉 大介, 村上 理一 :** TiN膜の熱処理により作製したTi-O-N膜の光分解特性, *日本材料学会第58期学術講演会,* 193-194, 2009年5月.
67. **谷本 翔太, 米倉 大介, 村上 理一 :** CrN 薄膜を被覆したTi-6Al-4V 合金のフレッティング疲労特性, *日本機械学会2009年度年次大会講演論文集,* **Vol.4,** 167-168, 2009年9月.
68. **Pankaj Koinkar *and* Ri-ichi Murakami :** Internationalization of Graduate Education, *Fourth International Symposium: Development of the Global Double Degree Program, The University of Tokushima,* Dec. 2009.
69. **Pankaj Koinkar *and* Ri-ichi Murakami :** Analysis and review of Summer school program and Short-term study abroad program, *22 FD in,* Jan. 2010.
70. **Shamimur Md. Rahman, T. Katsuma, Daisuke Yonekura *and* Ri-ichi Murakami :** Evaluation of crack initiation and fatigue behavior of CrN film deposited on Ti-6Al-4V alloy, *International Journal of Modern Physics B,* **Vol.24,** *No.15n16,* 2502-2505, 2010.
71. **S. Fukui, Daisuke Yonekura *and* Ri-ichi Murakami :** Influence of Deposition Conditions on Fatigue Properties of Martensitic Stainless Steel with TiN Film Coated by Arc Ion Plating Method, *International Journal of Modern Physics B,* **Vol.24,** *No.15-16,* 3095-3100, 2010.
72. **Dongyan Zhang, Pangpang Wang, Ri-ichi Murakami *and* Song Xiaoping :** Effect of an interface charge density wave on surface plasmon resonance in ZnO/Ag/ZnO thin films, *Applied Physics Letters,* **Vol.96,** *No.23,* 233114, 2010.
73. **Pangpang Wang, Lumei Gao, Liqun Wang, Dongyan Zhang, Sen Yang, Xiaoping Song, Zhiyong Qiu *and* Ri-ichi Murakami :** MAGNETIC PROPERTIES OF FENI NANOWIRE ARRAYS ASSEMBLED ON POROUS AAO TEMPLATE BY AC ELECTRODEPOSITION, *International Journal of Modern Physics B,* **Vol.24,** *No.15n16,* 2302-2307, 2010.
74. **Lee J. C., Ri-ichi Murakami *and* Suh M. C. :** FATIGUE PROPERIES OF ALUMINUM ALLOY(A6061-T6) WITH ULTRASONIC NANO-CRYSTAL SURFACE MODIFICATION, *International Journal of Modern Physics B,* **Vol.24,** *No.15,* 2512-2517, 2010.
75. **Cao J. X., Ri-ichi Murakami *and* Wang Y. Q. :** FATIGUE PROPERTIES OF Ti-6Al-4V SUBJECTED TO 0.9% PHYSIOLOGICAL SALINE SOLUTION, *International Journal of Modern Physics B,* **Vol.24,** *No.15,* 2518-2523, 2010.
76. **米倉 大介, 高橋 雅也, 村上 理一, 加藤 雅裕, 大西 賢治 :** シリカ粉体の付着・堆積挙動に及ぼす鋼板表面研磨処理の影響, *日本機械学会論文集(C編),* **Vol.76,** *No.767,* 1838-1843, 2010年.
77. **Cao X.J., Pyoun Y.S. *and* Ri-ichi Murakami :** Fatigue properties of a S45C steel subjected to ultrasonic nanocrystal surface modification, *Applied Surface Science,* **Vol.256,** *No.21,* 6297-6303, 2010.
78. **Chang Huang, Pangpang Wang, Wen Guan, Sen Yang, Lumei Gao, Liqun Wang, Xiaoping Song *and* Ri-ichi Murakami :** Improved microstructure and magnetic properties of ironcobalt nanowire via an ac electrodeposition with a multistep voltage, *Materials Letters,* **Vol.64,** *No.22,* 2465-2467, 2010.
79. **Krishal Patel, Colin S. Doyle, Daisuke Yonekura *and* Bryony J. James :** Effect of surface roughness parameters on thermally sprayed PEEK coatings, *Surface & Coatings Technology,* **Vol.204,** *No.21-22,* 3567-3572, 2010.
80. **Daisuke Yonekura, Katsuhiro Fujikawa *and* Ri-ichi Murakami :** Influence of film structure on gas barrier properties of SiOxNy films, *Surface & Coatings Technology,* **Vol.205,** *No.1,* 168-173, 2010.
81. **Dongyan Zhang, Pangpang Wang, Ri-ichi Murakami *and* Song Xiaoping :** Response to Comment on Enhancement of light transmission by coupling to surface plasmon polaritons of a layer-plus-islands silver layer [ J. Appl. Phys. 106, 103104 (2009) ], *Journal of Applied Physics,* **Vol.108,** *No.8,* 086103-086104, 2010.
82. **Pangpang Wang, Dongyan Zhang, Huang Chang, Song Xiaoping *and* Ri-ichi Murakami :** Surface Plasmon Resonant Enhanced Optical Transmission through ZnO/Ag/ZnO Multilayered Films, *Advances in Materials Science for Environmental and Nuclear Technology,* **Vol.222,** 287-294, 2010.
83. **Pankaj Koinkar, Sandip S. Patil, Tae-Gyu Kim, Daisuke Yonekura, Mahendra A. More, Dilip S. Joag *and* Ri-ichi Murakami :** Enhanced field emission characteristics of boron doped diamond films grown by microwave plasma assisted chemical vapor deposition, *Applied Surface Science,* **Vol.257,** *No.6,* 1854-1858, 2011.
84. **Dongyan Zhang, Pangpang Wang, Ri-ichi Murakami *and* Song Xiaoping :** First-principles simulation and experimental evidence for improvement of transmittance in ZnO films, *Progress in Natural Science : Materials International,* **Vol.21,** *No.1,* 40-45, 2011.
85. **Yun-Hae Kim, Young-Dae Jo *and* Ri-ichi Murakami :** A computational analysis of the scarf angle on a composites repair, *International Journal of Ocean System Engineering,* **Vol.1,** *No.1,* 9-15, 2011.
86. **米倉 大介, 高橋 雅也, 村上 理一, 加藤 雅裕, 大西 賢治 :** 表面研磨処理を施した鋼板の粉体付着抑制効果に及ぼす粒子径の影響, *日本機械学会論文集(C編),* **Vol.77,** *No.775,* 1161-1170, 2011年.
87. **米倉 大介, 村上 理一 :** PVDコーティング材のフレッチング疲労, *トライボロジスト,* **Vol.55,** *No.10,* 708-713, 2010年10月.
88. **Daisuke Yonekura, Yuta Fujie, Hayato Nishii, Hiroshi Yamakawa *and* Ri-ichi Murakami :** Influence of Heat Treatment on Fatigue Strength of Drawn Steel Tubes for Small-sized Single Pass Boiler, *International Conference on Structural Integrity and Failure 2010,* Auckland, Jul. 2010.
89. **Cao Xiaojian, Yan Fan, Ri-ichi Murakami *and* Onizawa Atsushi :** Fatigue Properties of a S45C Steel with Plasma Nitriding, *International Conference for SIF2010,* Jul. 2010.
90. **Ri-ichi Murakami :** Improvement of Optical Transmission and Conductivity in a Symmmetric Zno/Ag Multilayered films, *The 11th IUMRS International Conference in Asia,* Sep. 2010.
91. **Ri-ichi Murakami :** Improvement Mechanism of Extraordinary Optical Transmission in a Dielectric/metal/dielectric Multilayer Thin Films, *2010 Inetrnational Conference on Optics and Photonics in Taiwan,* Tainan, Dec. 2010.
92. **薄木 航, 米倉 大介, 村上 理一 :** ナノインデンテーション法を用いたPVD 薄膜の破壊靭性の評価, *日本機械学会2010年度年次大会講演論文集,* **Vol.1,** 313-314, 2010年9月.
93. **谷本 翔太, 米倉 大介, 村上 理一 :** 硬質薄膜を被覆したチタン合金のフレッティング疲労特性, *日本機械学会2010年度年次大会講演論文集,* **Vol.1,** 315-316, 2010年9月.
94. **小林 大士, 米倉 大介, 村上 理一 :** SiOxNy膜を被覆したガスケット用ゴムシートの熱酸化劣化特性, *日本機械学会中国四国支部・九州支部合同企画 徳島講演会講演論文集, No.105-2,* 23-24, 2010年10月.
95. **能田 光, 米倉 大介, 村上 理一 :** アルミニウム合金基板に被覆したCrN薄膜の密着性に及ぼす基板前処理の影響, *日本機械学会中国四国支部・九州支部合同企画 徳島講演会講演論文集, No.105-2,* 25-26, 2010年10月.
96. **石川 洋三, 米倉 大介, 村上 理一 :** MPCVD法により成膜した導電性ダイヤモンド薄膜の表面化学修飾の評価, *日本機械学会中国四国支部・九州支部合同企画 徳島講演会講演論文集, No.105-2,* 27-28, 2010年10月.
97. **加藤 雅裕, 米倉 大介, 高橋 雅也 :** 新しい付着抑制表面処理を施した鋼表面への粉体の付着挙動の解析, *徳島大学大学院ソシオテクノサイエンス研究部研究報告, No.55,* 19-24, 2010年6月.